OST Ostschweizer

Fachhochschule

Microtechnology Approaches for Customized Photonic Packages

Swiss PIC Event – Photonics Integration and Packaging Neuchatel '24

Tobias Lamprecht

IMP - Institute for Microtechnology and Photonics School of Technology

Folienlayout

Outline

- Who we are
- Offering: Development in Miniaturization and Customization of Devices
- Examples





IMP Institute for Microtechnology and Photonics

10.01



MEMS for medical, environmental, industrial applications in a connected world.

IMP Institut für Mikrotechnik und Photonik

Cleanroom

Wafer processing and for innovative microsystems





Materials

Analysis and design of customer-specific materials

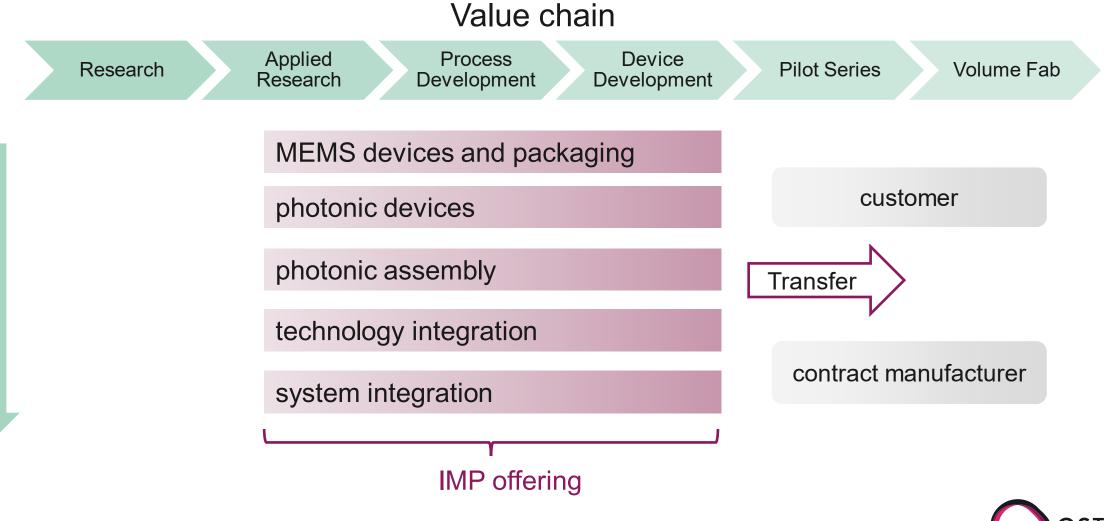


Dimensions, shape, surface roughness at highest precision



Position in the Value Chain

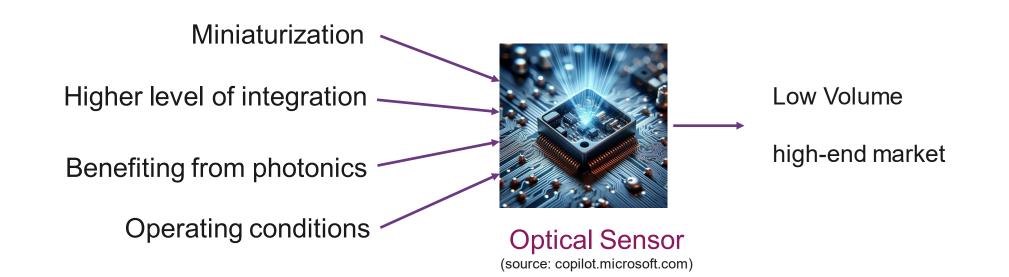
IMP Institut für Mikrotechnik und Photonik



Technologies

Typical Requests

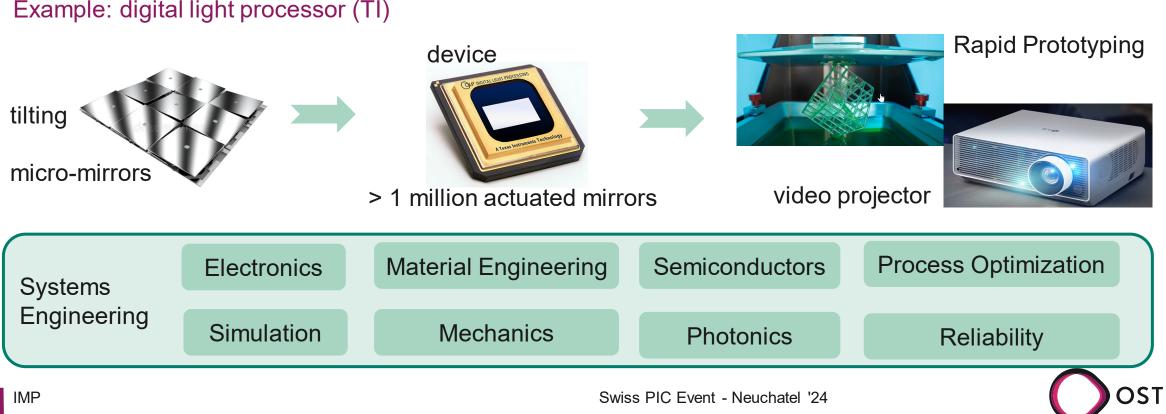
- Start-ups, SMEs to larger companies
- Complementing customers in-house technologies or providing full technology stack





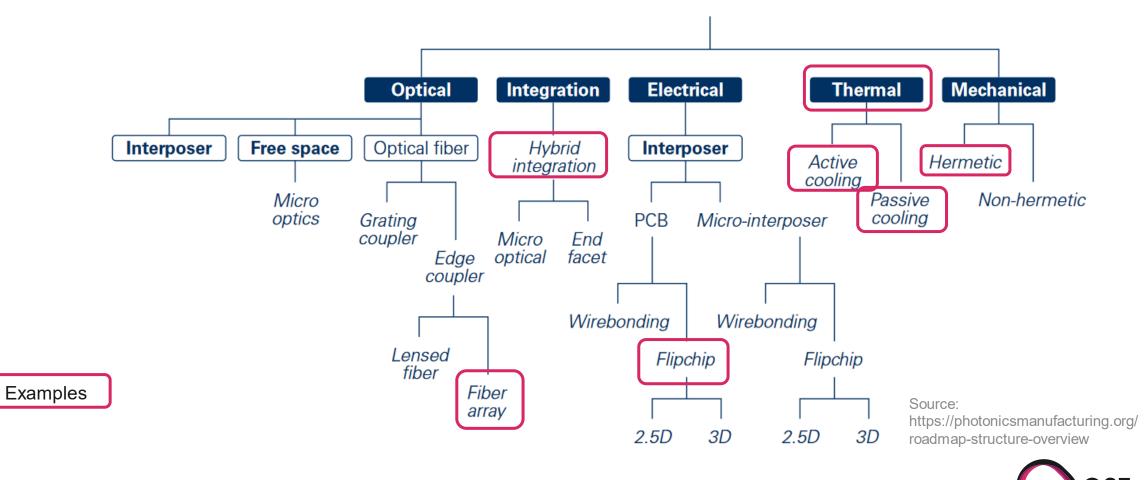
Systems Engineering for Miniaturized Optical Systems

- Efficient miniaturization
 - High-level of integration \rightarrow Systems engineering ٠
 - Holistic development across disciplines (mech, optical, electrical, assembly, packaging, etc...) •



Systems Engineering

• Photonic devices: multi-domain systems

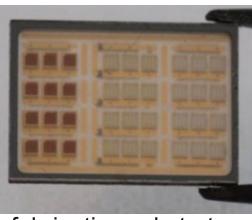


PHOTONIC DEVICE

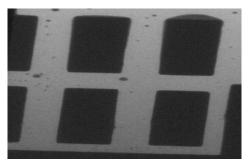
Packaging Example

Hermetic LED Package

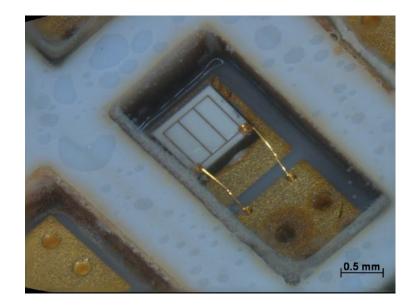
- Combination of various materials (ceramic, glass,...)
- Hermetic
- Autoclavable 2000+ cycles
- Glass soldering



fabrication substrate



Nearly defect free bonding



LED in ceramic frame



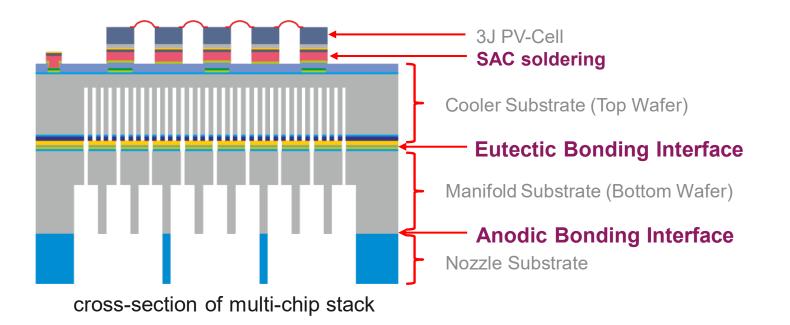
Packaging Example

Packaging of High-Power Photovoltaic Module

- Thermal cooling of photovoltaic \rightarrow thermal energy harvesting
- Reliable joining technologies on large areas
- Various materials



Assembled module





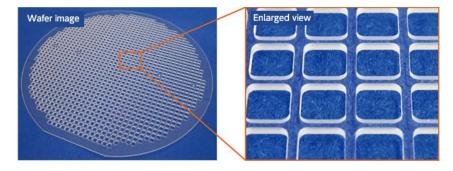
Microtechnology – Potential for Miniaturization of Photonics

- Foster innovation by cross-technology developments
- Potential topics for joint developments of optics and microtechnology
 - Assembly utilities using mechanical alignment on wafer-level
 - Wafer-level based subassemblies
 - Microtechnology based subassemblies

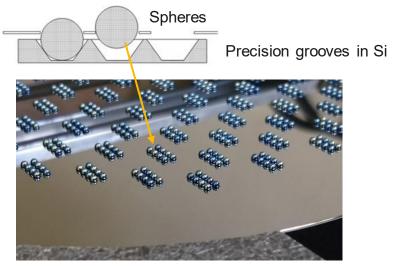


Microtechnology – Mechanical Alignment Concept

- Accurate positioning (micrometer): mechanical datum
- Assembly direct on substrates
- Precision tooling, utilities (transfer, pre-alignment)
- Wafer-level passive assembly



Precision spacers or apertures Source: www.tecnisco.com/



Ball lenses assembled in carrier wafer for IR sensor wafer stack Source: A. Kulkarni; ISBN: 978-0-9988782-1-8



Hundreds of identical devices per wafer Source: www.alamy.com

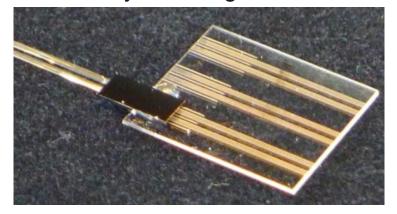


Packaging Example

Fiber to Waveguide - Passive Alignment

- Custom fiber array < ±1µm positioning accuracy (IL)
- Silicon based micro-mechanical bench

Fiber array to waveguide board



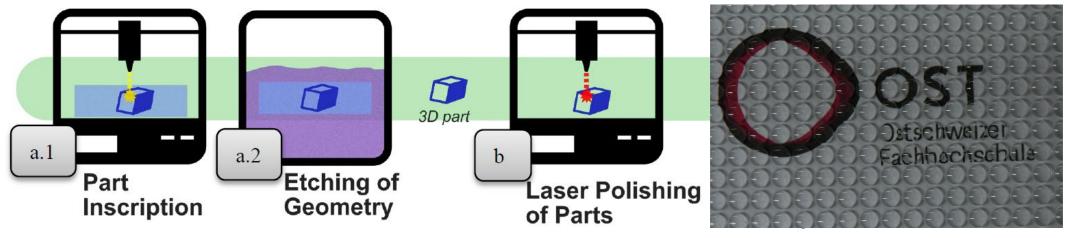
Fiber array in custom v-groove device



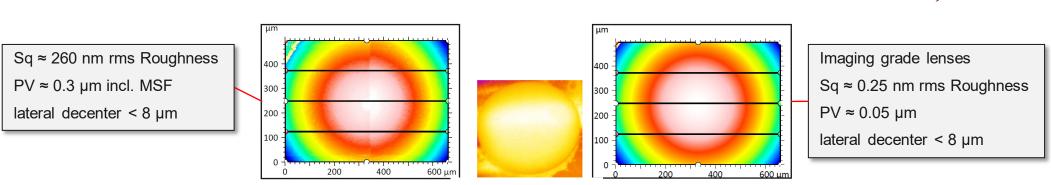


Source: OST (NTB), J. Kremmel, urn:nbn:de:gbv:ilm1-2019000511

Contactless Micro-Optics Manufacuring @ OST: the Selective Laser Etching (SLE) – Laser Polishing LP) Chain



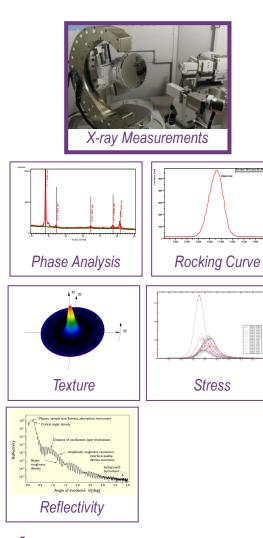
Lens array fabricated by SLE and laser polishing

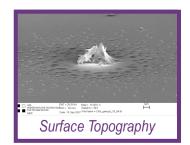


Lens dia. <1mm



Analytics – Expertise to Support Industry





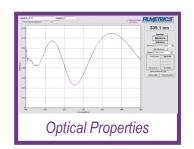


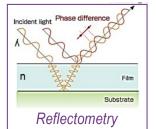
SEM / EDX

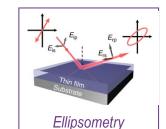


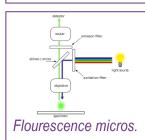
AFM / Profilometer















Nanoindenter



Shear-test



Advancing Photonics with MEMS

Contact Information

Tobias Lamprecht Head of Institute IMP IMP Institute for Microtechnology und Photonics OST Fachhochschule - Campus Buchs tobias.lamprecht@ost.ch +41 58 257 34 22

Your attention is kindly appreciated.

Q&A



